



In re Application of

David S. KUO, et al.

Serial No.:

Group Art Unit:

Filed: October 12, 2001

Examiner:

For:

PATTERNING OF HIGH COERCIVITY MAGNETIC MEDIA BY ION

IMPLANTATION

CLAIM OF PRIORITY

Commissioner for Patents Washington, DC 20231

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

U.S. Provisional Patent Application Serial No. 60/254,220, filed December 7, 2000

cited in the Declaration of the present application.

Respectfully submitted,

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